



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: WATANABE, et al.

Group Art Unit: 2825

Serial No.: 09/320,271

Examiner: Calvin Lee

Filed: May 27, 1999

P.T.O. Confirmation No.: 4409

For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREOF

AMENDMENT AFTER FINAL REJECTION

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

January 14, 2004

Sir:

In response to the Office Action dated **October 17, 2003**, please amend the above-identified application as follows:

RECEIVED  
JAN 20 2004  
TC 2800 MAIL ROOM

OK TO ENTER  
CL